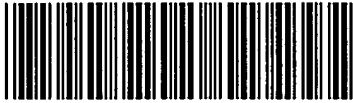


**Search Notes**

Application/Control No.

10/753,418

Examiner

Steven D. Maki

Applicant(s)/Patent under  
Reexamination

METZGER, JULIEN

Art Unit

1733

**SEARCHED**

Class	Subclass	Date	Examiner
152	209.21		
	209.23		
	Dig.3		
updated	search	6/10/2006	<i>SDM</i>

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
none	6/10/2006	<i>SDM</i>